

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
**PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION**

*sgd*  
*#519*  
*3-25-02*

APPLICANT: Takeshi Nogami, et al. ATTY. DOCKET NO. 09792909-5092  
SERIAL NO.  
DATE FILED:  
INVENTION: "SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD  
THEREOF"

Assistant Commissioner of Patents  
Washington, D.C. 20231

S I R:

Between the title and the heading "Background of the Invention" on page 1, insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application No. P2000-224884 filed July 26, 2000, which application is incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

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